

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 7, 2024

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

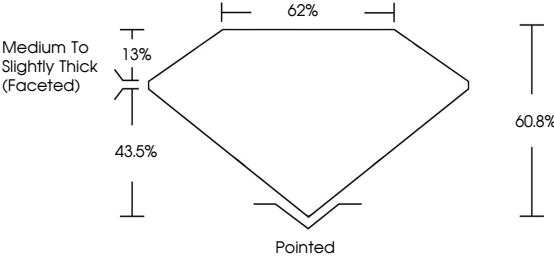
INSCRIPTION(S)

COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

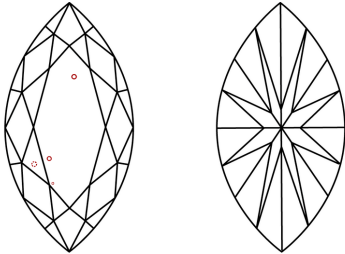
LG656414719

Report verification at igi.org

PROPORTIONS




CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

SAMPLE IMAGE USED



COLOR


D E F G H I J


Faint Very Light Light

CLARITY

IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included






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LABORATORY GROWN DIAMOND

MARQUISE BRILLIANT

14.36 X 7.76 X 4.72 MM

3.00 CARATS

E

SI 1

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INSCRIPTION(S)

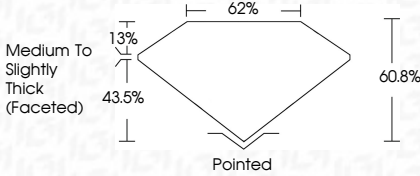
COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

EXCELLENT

EXCELLENT

NONE

LG656414719



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EXCELLENT

EXCELLENT

NONE

LG656414719



IGI

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IGI Report No LG656414719

MARQUISE BRILLIANT

14.36 X 7.76 X 4.72 MM

3.00 CARATS

E

SI 1

60.8%

62%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG656414719

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